

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	S.V. Sreenivasan et al.	Art Unit :	1732
Serial No. :	10/788,700	Examiner :	Matthew J. Daniels
Filed :	February 27, 2004	Conf. No. :	6995
Title :	FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT LITHOGRAPHY		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

In response to the Office Action having a mailing date of March 23, 2007, with a three-month shortened statutory period set to expire on June 23, 2007, please amend the above identified application as follows: